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Application No. 10/524,525 is being
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2007.

/David H. Brinkman/ 7/13/07
David H. Brinkman, Reg. No. 40,532 Date

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Martin Hausner
Serial No.: 10/524,525
Filed: August 18, 2005
Confirmation No.: 1134
Group Art Unit: 1765
Examiner: Ahmed, Shamim
Title: **METHOD FOR SELECTIVELY REMOVING MATERIAL FROM
THE SURFACE OF A SUBSTRATE, MASKING MATERIAL FOR
A WAFER, AND WAFER WITH MASKING MATERIAL**
Atty. Docket: BEET-09

Cincinnati, Ohio 45202

July 13, 2007

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action mailed on April 13, 2007, please amend
the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page
2 of this paper.

Amendments to the Abstract begin on page 12 of this paper.

Remarks/Arguments begin on page 13 of this paper.